



SIW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
ATTORNEY DOCKET NO. 039262-0156

Applicants: Tadahiro OHMI et al

Title: METHOD OF MANUFACTURING A SEMICONDUCTOR  
DEVICE AND METHOD OF ETCHING AN INSULATING  
FILM

Appl. No.: 10/588,698

Filing Date: 08/08/2006

Examiner: Caridad Everhart

Art Unit: 2895

Confirmation  
Number: 9929

**REQUEST TO PLACE DOCUMENTS IN PATENT FILE**  
**UNDER 37 C.F.R. § 1.97(i)**

**MAIL STOP: ISSUE FEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. Applicants request that the listed documents be placed of record in the file of this application.

The listed documents were cited during a search of the corresponding European application, a copy of the European Search Report is enclosed.

Respectfully submitted,

*George C. Beck* Reg. No. 61,092  
George C. Beck  
Attorney for Applicant  
Registration No. 38,072

April 13, 2009  
Date

FOLEY & LARDNER LLP  
Customer Number: 22428  
Telephone: (202) 945-6014  
Facsimile: (202) 672-5399